INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 12, 2026

IGI Report Number	LG837674979
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	HEXAGONAL MODIFIED STEP CUT
Measurements	14.62 X 8.45 X 5.20 MM

GRADING RESULTS

Carat Weight	4.89 CARATS
Color Grade	E
Clarity Grade	VVS 1

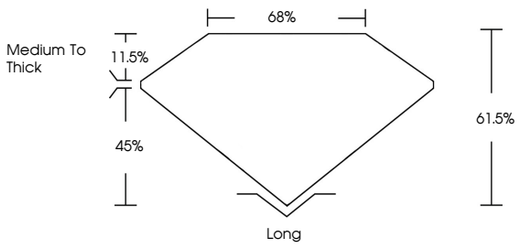
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG837674979

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG837674979
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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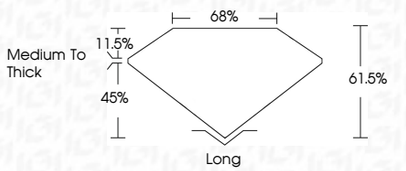
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www.igi.org

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IGI

September 12, 2026
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HEXAGONAL MODIFIED STEP CUT
14.62 X 8.45 X 5.20 MM
Carat Weight 4.89 CARATS
Color Grade E
Clarity Grade VVS 1
Depth 61.5%
Table 68%
Girdle Medium To Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG837674979
Comments:
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Type IIa